

Docket No.: K-281

PATENT

JC971 U.S. PRO
09/848283
05/04/01


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :
Tae Hoon LEE :
Serial No. New U.S. Patent Application :
Filed: May 4, 2001 :
For: TENSION MASK ASSEMBLY

AUTHORIZATION TO TREAT A REPLY AS INCORPORATING
AN EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a)(3)

Assistant Commissioner for Patents
Washington, D. C. 20231

Sir:

The U.S. Patent and Trademark Office is hereby authorized to treat any concurrent or future reply that requires a petition for an extension of time under this paragraph for its timely submission, as incorporating a petition for extension of time for the appropriate length of time under 37 C.F.R. 1.136(a)(3). The U.S. Patent and Trademark Office is hereby authorized to charge all required extension of time fees to our Deposit Account No. 16-0607, if such fees are not otherwise provided for in such reply. A duplicate copy of this sheet is enclosed.

Respectfully submitted,
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Date: May 4, 2001